PATENT

SEP 2 3 2004 E

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Jae Han CHA

Serial No.: 10/612,074

Group Art Unit: 2823

Filed: July 3, 2003

Examiner: Estrada, Michelle

For: METHOD OF FORMING AN ISOLATION FILM IN A SEMICONDUCTOR DEVICE

TRANSMITTAL

Honorable Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 September 23, 2004

Transmitted herewith is an Amendment and a Change of Address.

The fee has been calculated as shown below:

| | Claims | | Highest | Present | Small Entity | y Other Than A |
|---|-----------|---|------------|--------------|--------------|------------------|
| | Remaining | | Number | Extra | | Small Entity |
| | After | | Previously | , | Rate Addit. | (or) Rate Addit. |
| | Amendment | | Paid For | | Fee | Fee |
| Total | 14 | - | 20= | 0 | x 09 = \$ | x 18 = \$ |
| Indep. | . 02 | - | 03= | 0 | x 42 = \$ | x 84 = \$ |
| First Presentation of Multiple Dependent Claims $\pm 140 = \$$ $\pm 280 = \$$ | | | | | | |
| Total Additional Fee S \$ | | | | | | |

A check in the amount of \$_____is attached for Petition for One Month Extension of Time, and additional claims fee.

XXXX If a Petition for Extension of Time is necessary and the Petition and/or the check is not enclosed, this will act as the Petition and applicant herewith petitions the Commissioner to extend the time for response and charge any fees necessary under 37 CFR 1.17 (a)(1)-(5) to Deposit Account No. 50-1442. The Commissioner is also authorized to charge payment of any other additional fees associated with this communication or credit any overpayment to Deposit Account No. 50-1442. A duplicate copy of this sheet is attached.

Respectfully submitted,

Piper Rudnick, LLP

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Telephone: (202) 861-3871 Atty. Docket: 312971-P0023

YSH:jr

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DEVICE

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AMENDMENT

Honorable Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 September 23, 2004

Sir:

Responsive to the Office Action mailed August 5, 2004 (Paper No. 20040804), kindly enter the following amendments and remarks.